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Atty. Docket No.: 005040/TCG/PMD/LE (BSTZ Ref. No.: 004887.P522) Patent  
Confirmation No.: 7268

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In Re Application of: )

Don E. Curry, et al. )

Application No: 09/828,067 )

Filed: April 6, 2001 )

For: A WAFER PROCESSING APPARATUS )  
HAVING A CHAMBER WITH AN UPPER )  
WALL HAVING GAS SUPPLY OPENINGS )  
FORMED THEREIN WHICH PROMOTE )  
MORE EVEN PROCESSING OF A WAFER )

Examiner: Zervigon, Rudy

Art Unit: 1763

Mail Stop: Amendment  
Commissioner For Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE TO OFFICE ACTION

Dear Sir:

In response to the Office Action dated October 3, 2005, Applicant respectfully requests that the above-identified application be amended as follows and that the following remarks be considered:

FIRST-CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail with sufficient postage in an envelope addressed to Mail Stop: Amendment, Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450, on:

January 3, 2006  
Date of Deposit

Dianne Neathery  
Name of Person Mailing Correspondence

Dianne Neathery  
Signature

January 3, 2006  
Date

Inventor(s): Don E. Curry et al.  
Application No.: 09/828,067

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Examiner: Zervigon, Rudy  
Art Unit: 1763